CLAIMS

- 1 1. An electrostatic discharge (ESD) protective structure that protects an integrated
- 2 semiconductor circuit connected between a first potential bus with a first supply potential
- 3 (VCC) and a second potential bus with a second supply potential (VSS), said electrostatic
- 4 discharge protective structure comprising:
- a laterally formed electrostatic discharge diode having a first region doped with a
- 6 first conduction type and a second region, spaced apart from said first region;
- a doped second conduction type, wherein said electrostatic discharge protective
- 8 structure is located between the first and second potential busses and drains off an
- 9 overvoltage pulse to one fo the first and second potential busses, wherein said laterally
- formed electrostatic discharge diode includes a gate electrode located between said first
- region and said second region corresponding to the width (W) or the length of the gate
- 12 electrode.
- 1 2. The electrostatic discharge protective structure of claim 1, wherein said protective
- 2 structure includes a semiconductor body having a surface in which said first region and
- 3 said second region are embedded, wherein said first region is connected via a first
- 4 electrode to the first potential bus, and said second region is connected via a second
- 5 electrode to the second potential bus.
- 1 3. The electrostatic discharge protective structure of claim 2, wherein said
- 2 semiconductor body includes charge carriers of the second conduction type, and said gate



- 3 electrode and said second electrode are connected to said second potential bus.
- 1 4. The electrostatic discharge protective structure of claim 2, wherein said
- 2 semiconductor body includes charge carriers of the first conduction type, and at least one
- well of the second conduction type is embedded in said semiconductor body, and said first
- and second regions are embedded in said well.
- 1 5. The electrostatic discharge protective structure of claim 4, wherein said second
- 2 regions laterally enclose said first regions.
- 1 6. The electrostatic discharge protective structure of claim 4, wherein the integrated
- 2 semiconductor circuit is configured and arranged as an MOS or CMOS circuit.
- 1 7. The electrostatic discharge protective structure of claim 2, comprising a gate
- 2 dielectric that spaces said semiconductor body at a distance from the gate electrode.
- 1 8. The electrostatic discharge protective structure of claim 7, wherein said gate
- dielectric contains silicon dioxide and said gate electrode contains polysilicon.
- 1 9. A method for producing an electrostatic discharge protective structure that is co-
- 2 integrated into an integrated circuit with a circuit to be protected, and the electrostatic
- discharge protective circuit and the circuit to be protected are disposed electrically in
- 4 parallel between first and second voltage busses, said method comprising:
- 5 inserting doping atoms of a first conduction type for the first region;
- 6 inserting doping atoms of a second conduction type for the second region;

- applying a gate dielectric to the first surface over an enrichment region that is
- 8 located between the first region and the second region;
- applying a metallization or a polysilicon layer respectively to the first and second regions and to the gate dielectric.
 - 1 10. The method of claim 9, wherein said gate dielectric and said gate electrode are
 - 2 produced first, and then said first and the second regions are inserted in a self-adjusting
 - 3 manner into the semiconductor body using the gate dielectric as a mask.
- 1 11. The method of claim 10, wherein said step of inserting doping atoms of a first
- 2 conduction type for the first region includes the step of ion implantation of the doping
- 3 atoms into the first region.
- 1 12. The method of claim 10, wherein said integrated semiconductor circuit and said
- 2 electrostatic diode are produced in MOS/CMOS technology.
- 1 13. An integrated circuit with electrostatic discharge protection, said integrated circuit
- 2 comprising:
- a circuit to be protected;
- an electrostatic discharge device that is disposed electrically parallel to said circuit
- 5 to be protected between first and second voltage busses, wherein said electrostatic
- 6 discharge device includes a laterally shaped electrostatic discharge diode having:
- 7 (i) a first region doped with a first conduction type material within a

8	substrate;
9	(ii) a second region doped with a second conduction type material within
10	said substrate; and
11	(iii) a gate electrode having a width W and located between said first and
12	second regions such that said first and second regions are separated by the width
13	W.
1	14. The integrated circuit of claim 13, comprising a gate oxide disposed on said
2	substrate between said first and second conduction regions and underlying said gate
3	electrode.
1	15. The integrated circuit of claim 14, comprising a first electrode disposed on said
2	substrate overlaying said first region, and a second electrode disposed on said substrate
3	overlaying said second region, wherein said first electrode is connected to the first voltage

bus and said second electrode is connected to said second bus.